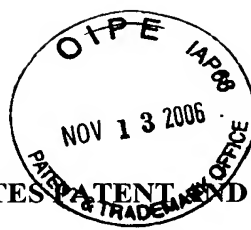


Docket No. 294455US0PCT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Hiroaki TAKEUCHI, et al.

SERIAL NO: 10/589,077

GAU: 2812

FILED: August 11, 2006

EXAMINER:

FOR: METHOD FOR PRODUCING SILICON OXIDE FILM

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- ☒ The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available Unedited Computer-Generated English translations of pertinent portions of any non-English language references.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- ☐ Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the attached PTO form 1449.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

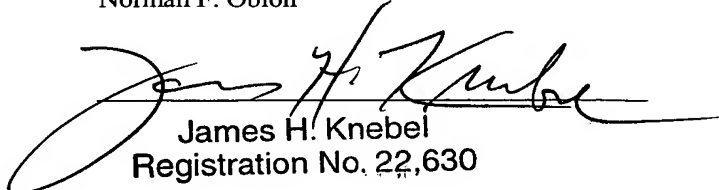
- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

- ☒ Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.
Norman F. Oblon


James H. Knebel
Registration No. 22,630

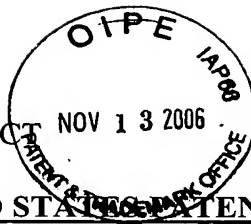
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Page 1 of 1



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STATEMENT OF RELEVANCY

Reference AO (JP 7-142578) on Form PTO-1449 is discussed in the specification.

Form PTO 1449
(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY DOCKET NO.

294455US0PCT

SERIAL NO.

10/589,077

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

Hiroaki TAKEUCHI, et al.

FILING DATE

August 11, 2006

GROUP

2812

U.S. PATENT DOCUMENTS

EXAMINER • INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	5,173,452	12/22/1992	David M. MOBUZINSKY, et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AO	7-142578	06/02/1995	JAPAN (with English Abstract and Unedited Computer-Generated English translation)	X	
	AP	2-263981	10/26/1990	JAPAN (with English Abstract, corr. US 5,173,452)		X
	AQ	2003-342731	12/03/2003	JAPAN (with English Abstract and Partial Unedited Computer-Generated English translation)	X	
	AR	11-12542	01/19/1999	JAPAN (with English Abstract and Unedited Computer-Generated English translation)	X	
	AS	2003-297832	10/17/2003	JAPAN (with English Abstract and Unedited Computer-Generated English translation)	X	
	AT					
	AU					
	AV					

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

	AW	
	AX	
	AY	
	AZ	

☐ Additional References sheet(s) attached

Examiner

Date Considered

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.